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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Yuchun Wang, Rajeev Bajaj and Fred C. Redeker  
Serial No. : 09/843,582  
Filed : April 26, 2001  
For : ION EXCHANGE PAD OR BRUSH AND METHOD OF  
REGENERATING THE SAME  
Examiner : Dung V. Nguyen  
Group Art Unit : 3723

Hon. Assistant Commissioner  
for Patents  
Washington, D.C. 20231

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TECHNOLOGY CENTER R3700

AMENDMENT

Sir:

In response to the Examiner's Office Action dated  
October 11, 2002, applicants amend the above-identified  
application as follows:

In the Claims

Please amend claims as follows:

14. A brush apparatus comprising:  
a scrubber brush having:  
a surface adapted to contact a surface of a  
substrate to be scrubbed; and